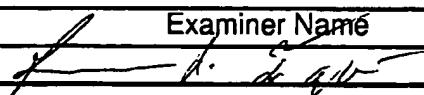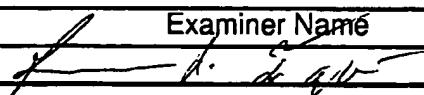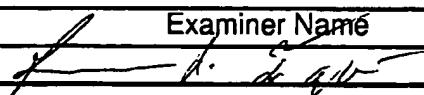# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention	HALO IMPLANT IN SEMICONDUCTOR STRUCTURES

Application Number :

Confirmation Number:

First Named Applicant: John Ellis-Monaghan

Attorney Docket Number: BUR920040160US1

Art Unit:

Examiner:

Search string: (5759901 or 5716862 or 5698869 or 5426063 or 5217913 or 6489223 or 6444548 or 6355512 or 5891792 or 5858831).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5759901	1998-06-02	Loh et al			
	2	5716862	1998-02-10	Ahmad et al			
	3	5698869	1997-12-16	Yoshimi et al			
	4	5426063	1995-06-20	Kaneko et al			
	5	5217913	1993-06-08	Watabe et al			
	6	6489223	2002-12-03	Hook et al			
	7	6444548	2002-09-03	Divakaruni et al			
	8	6355512	2002-03-12	Yamazaki et al			
	9	5891792	1999-04-06	Shih et al			
	10	5858831	1999-01-12	Sung			

Signature

Examiner Name	Date
	4/28/05